

[図1]

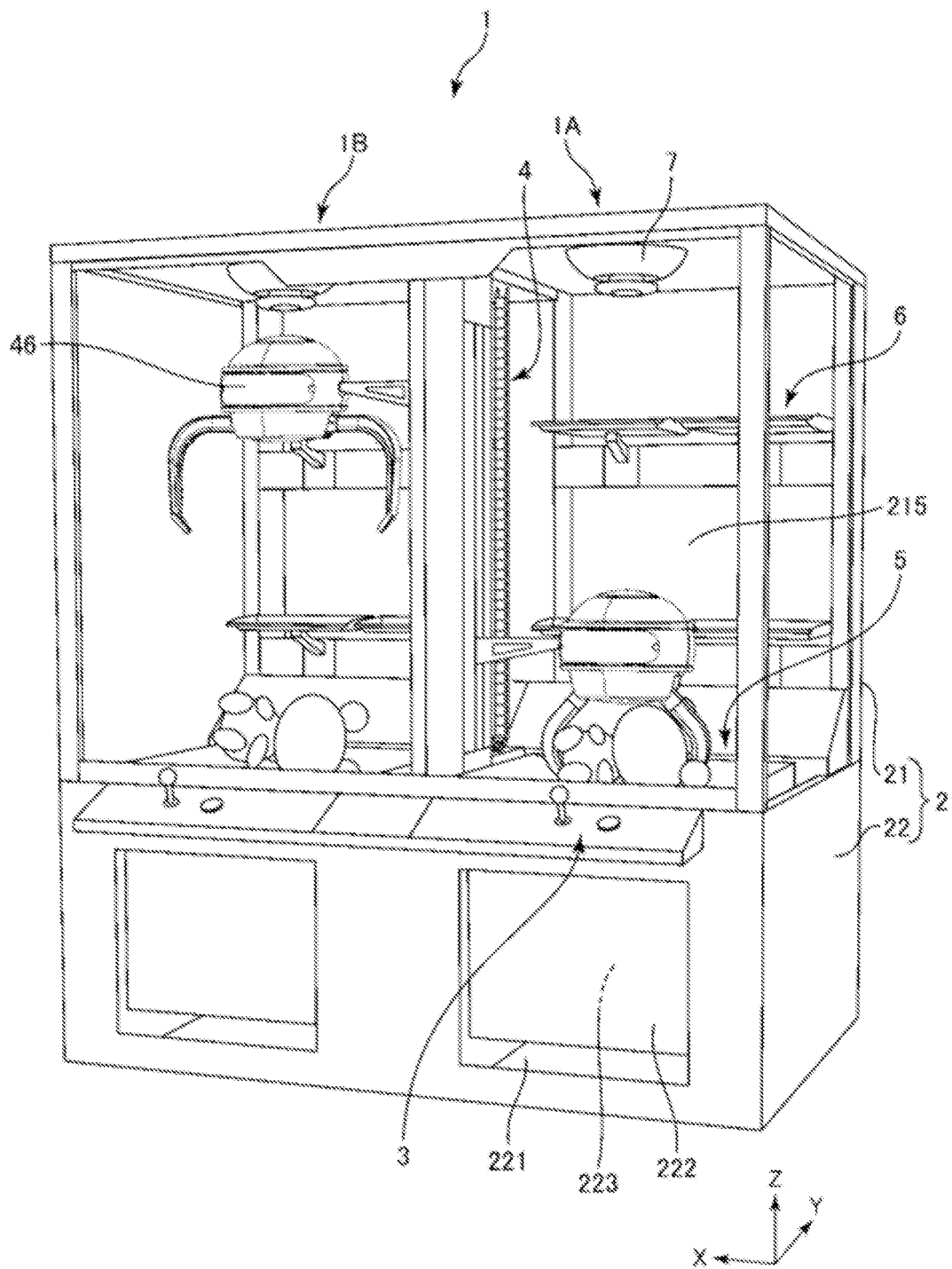


FIG.1

[図2]

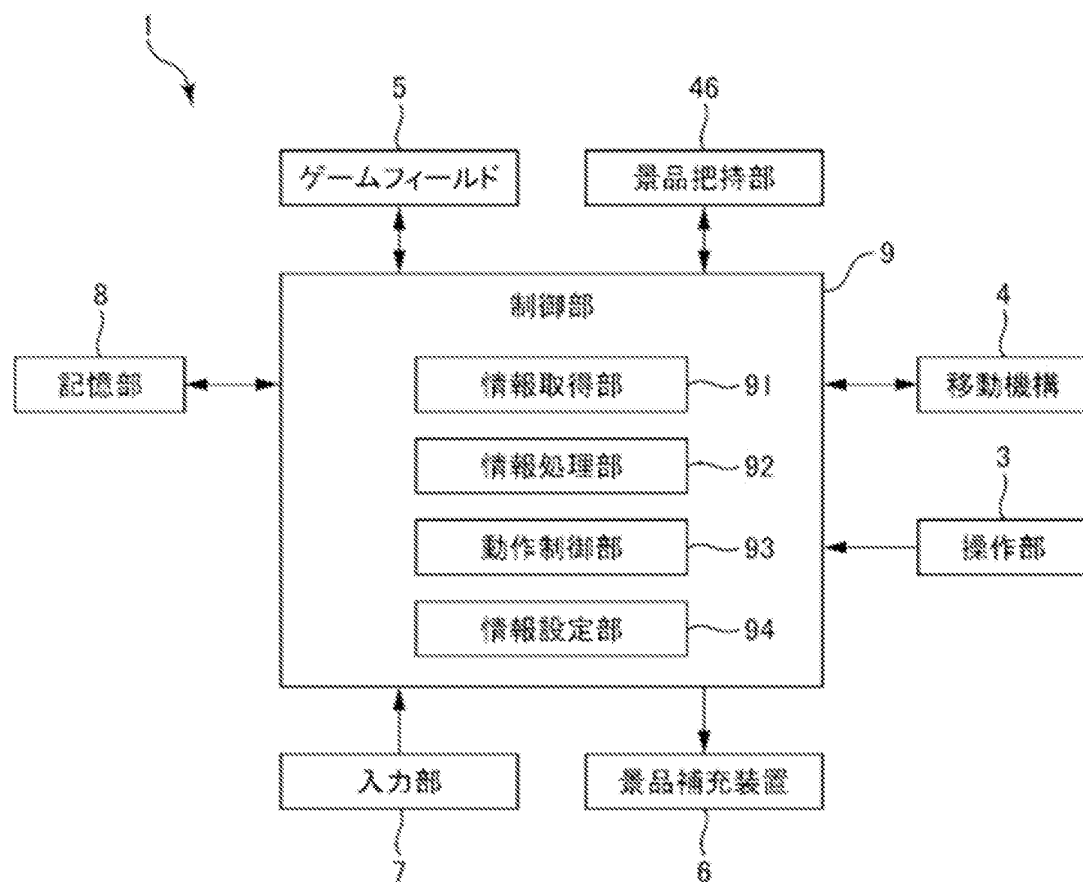


FIG.2

[図3]

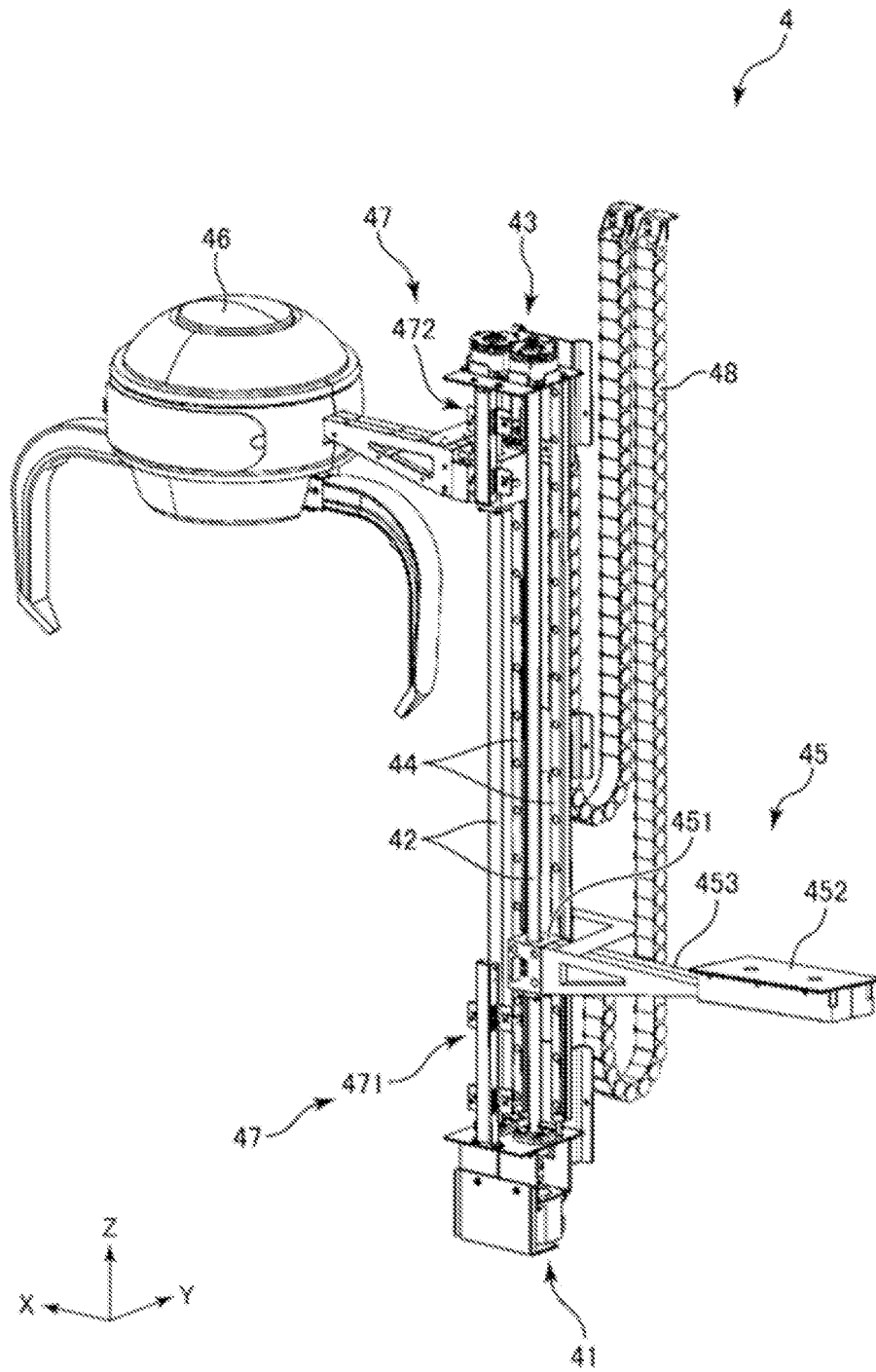


FIG.3

[図4]

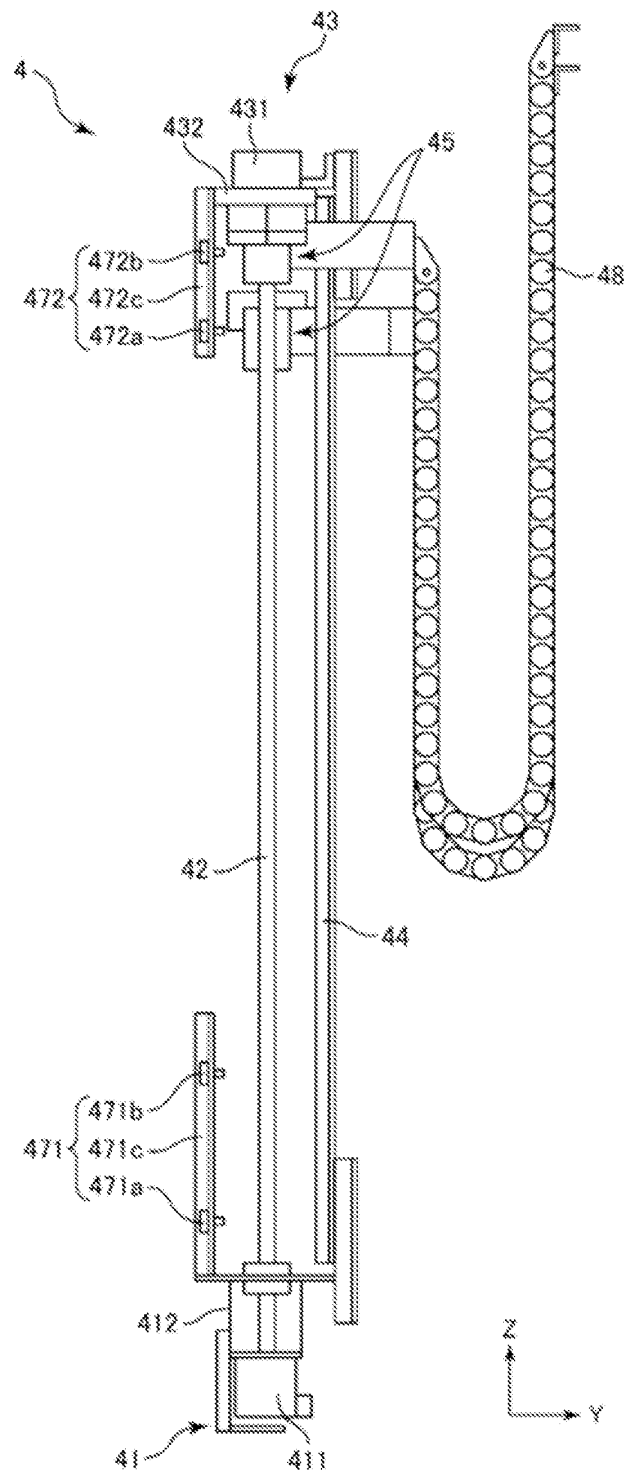


FIG.4

[図5]

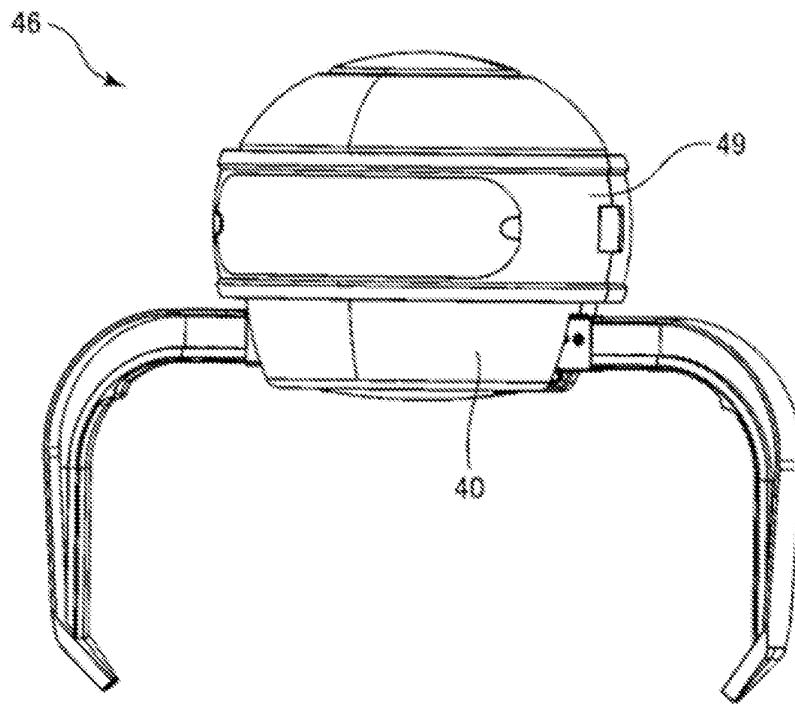


FIG.5

[図6]

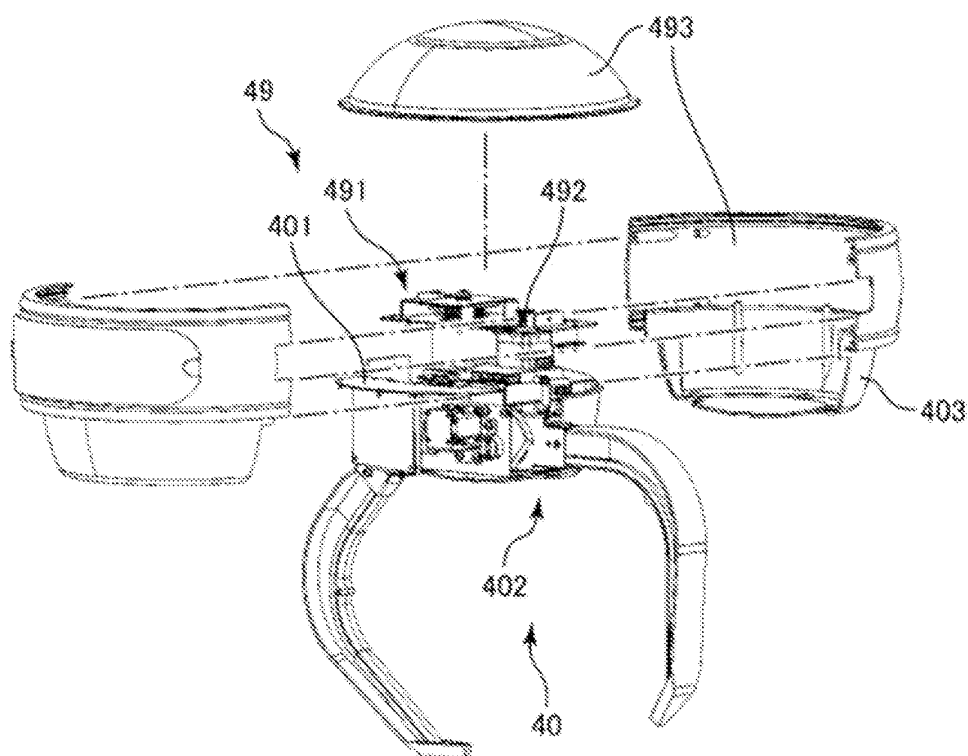


FIG.6

[図7]

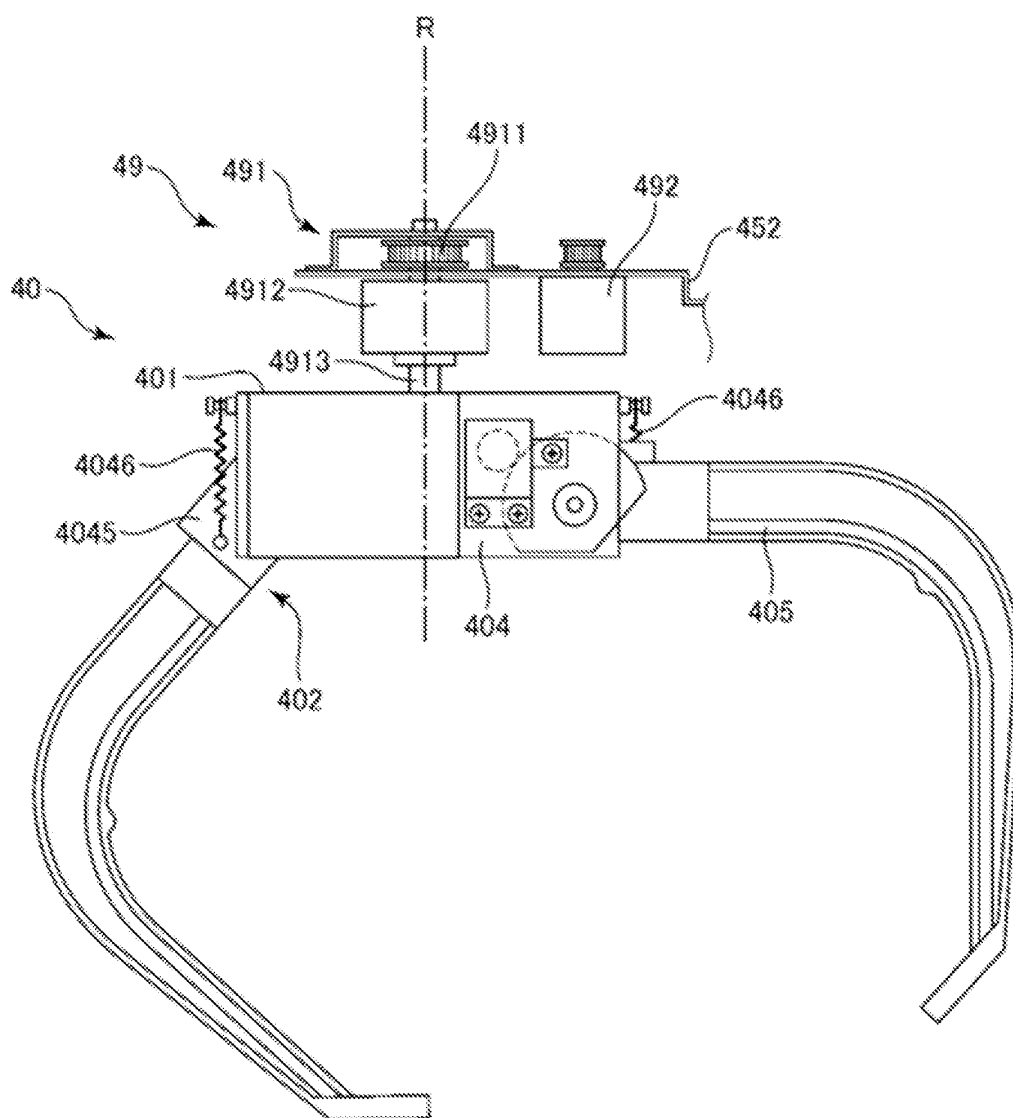


FIG.7

[図8]

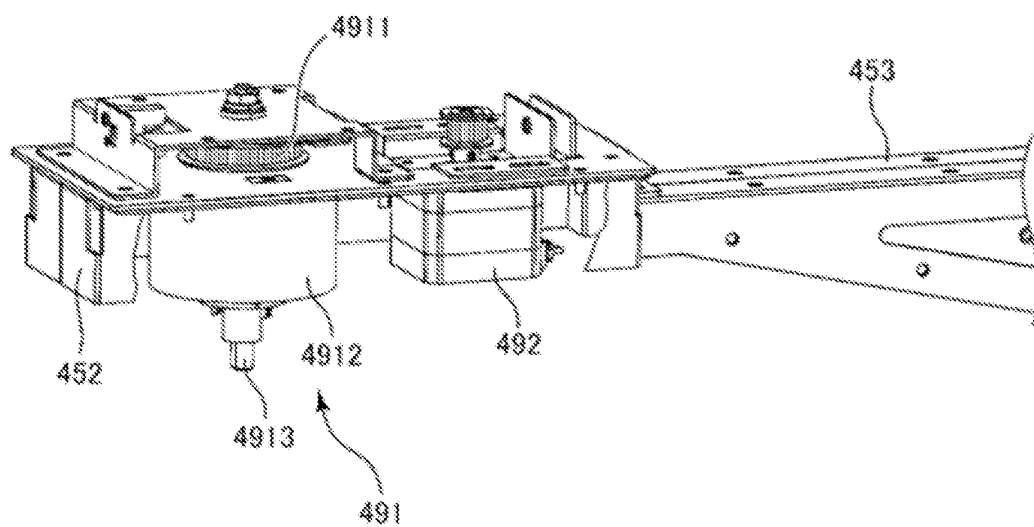


FIG.8

[図9]

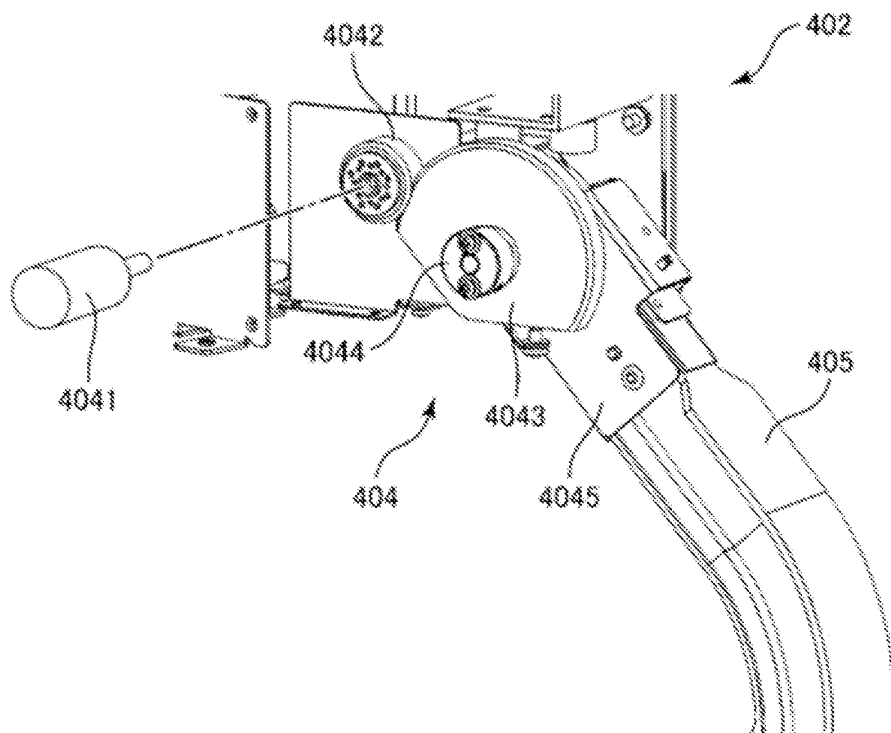


FIG.9

[図10]

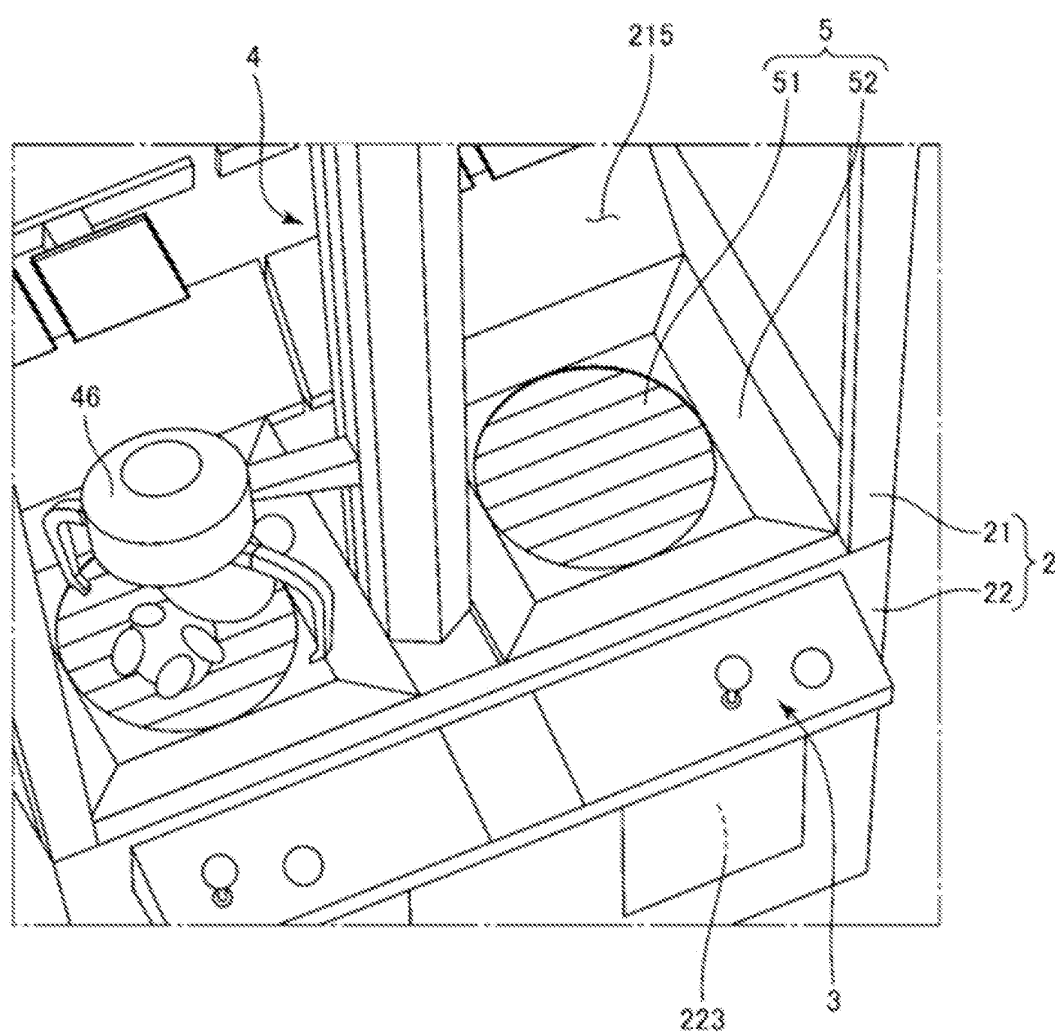


FIG.10

[図11]

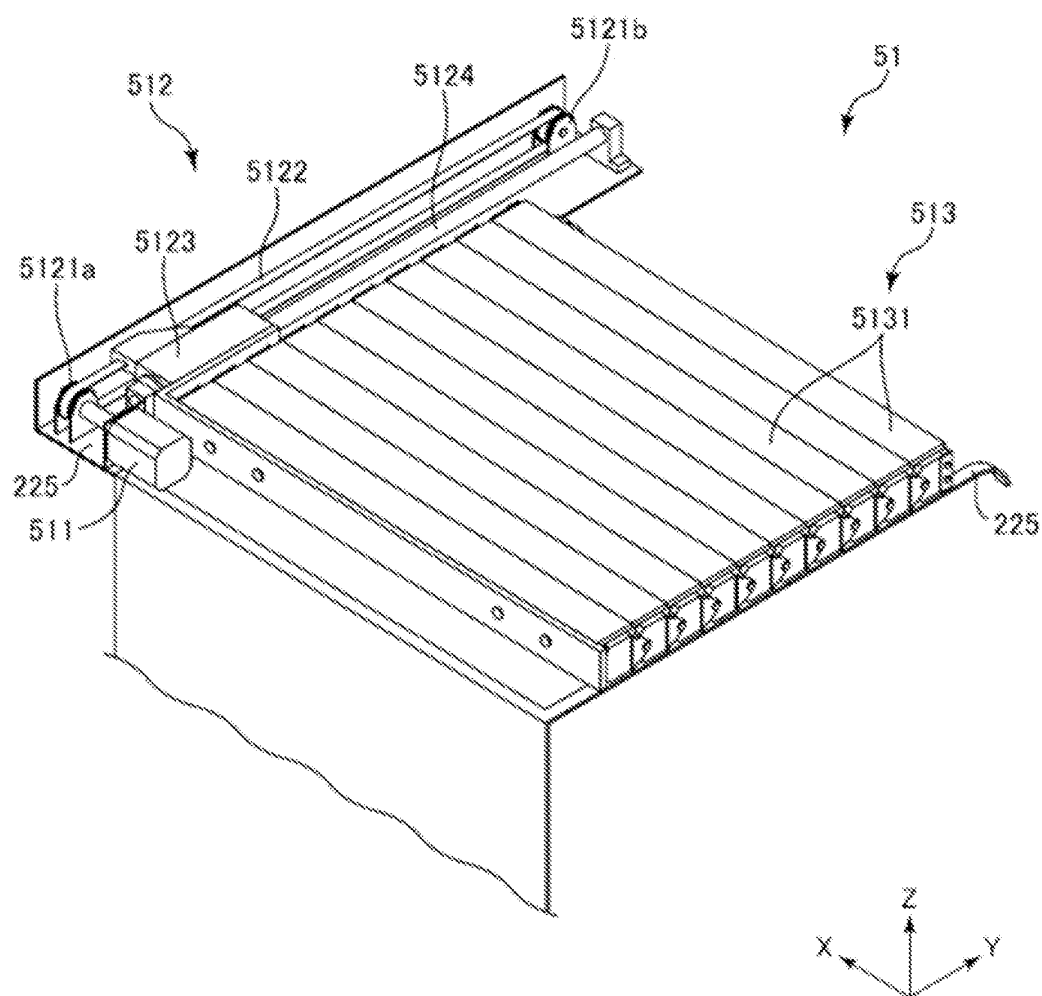


FIG.11

[図12]

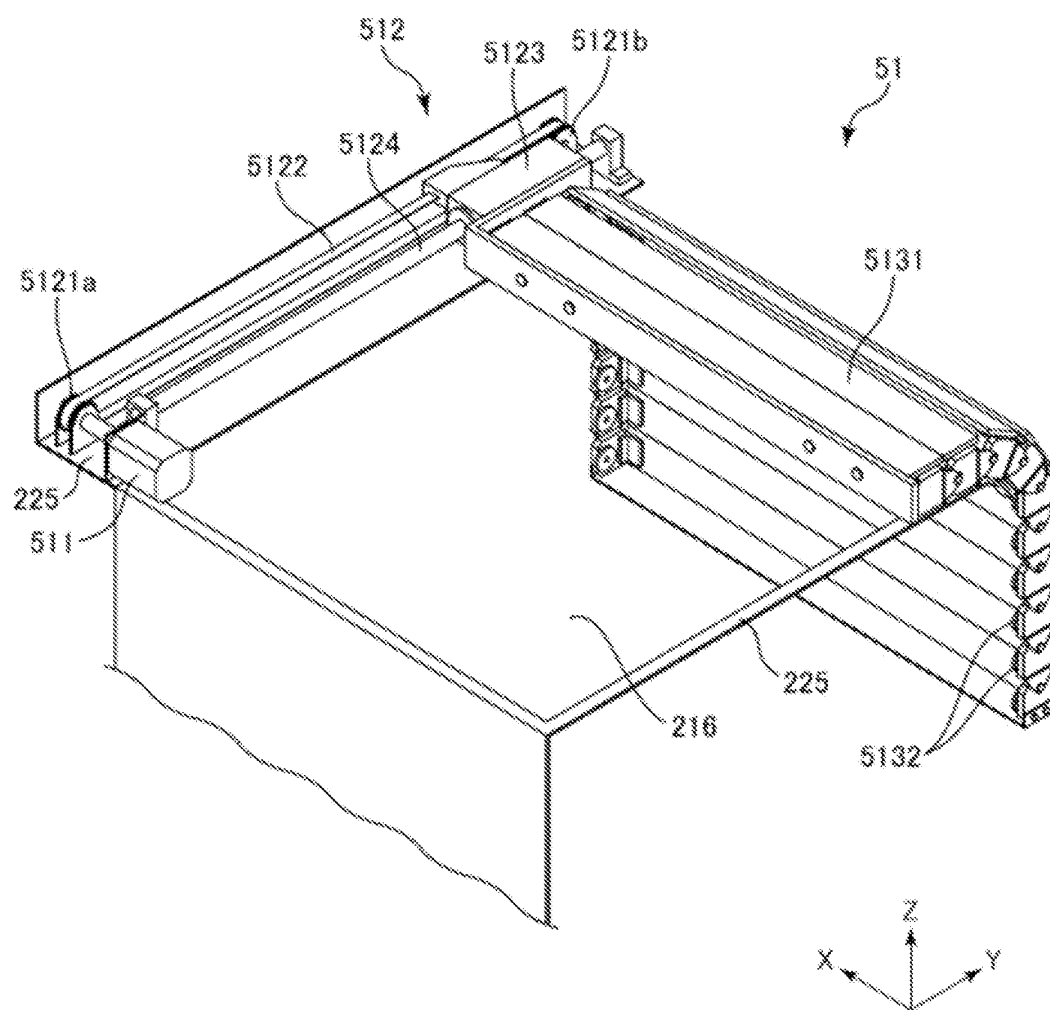


FIG.12

[図13]

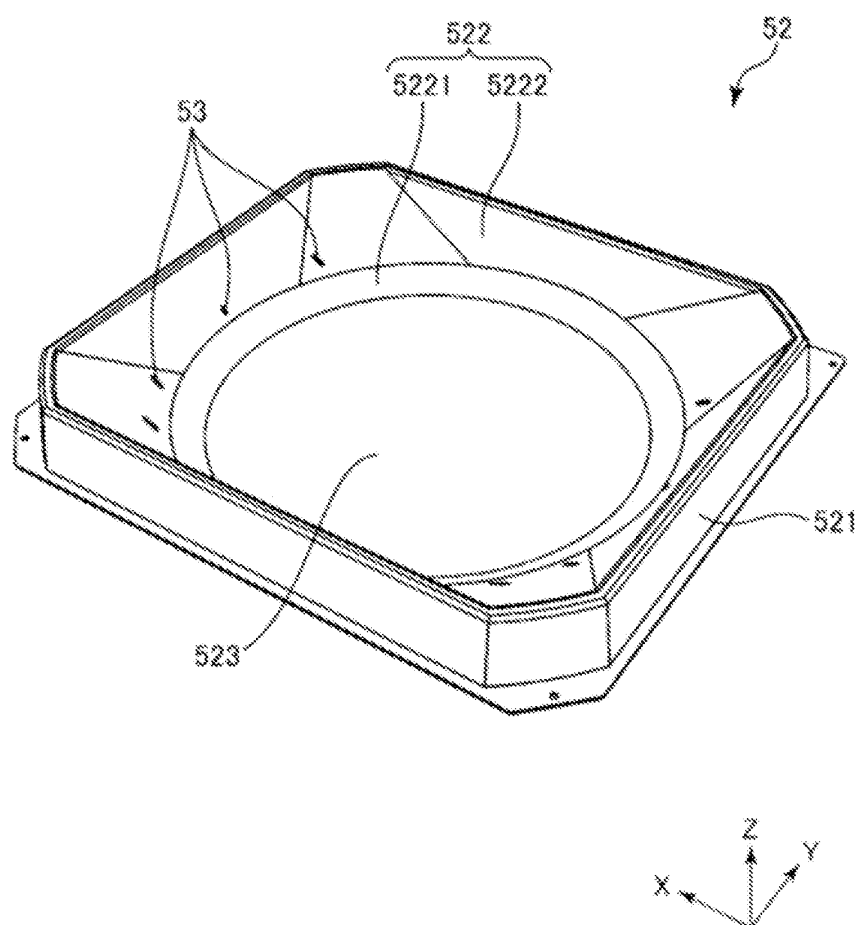


FIG.13

[図14]

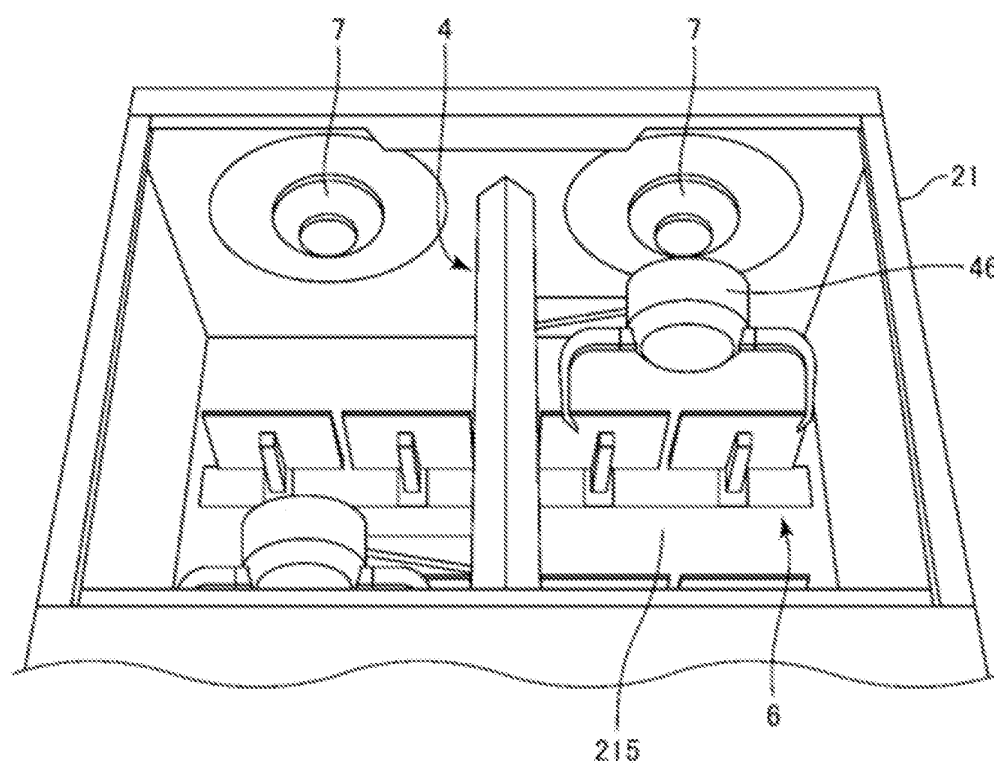


FIG.14

[図15]

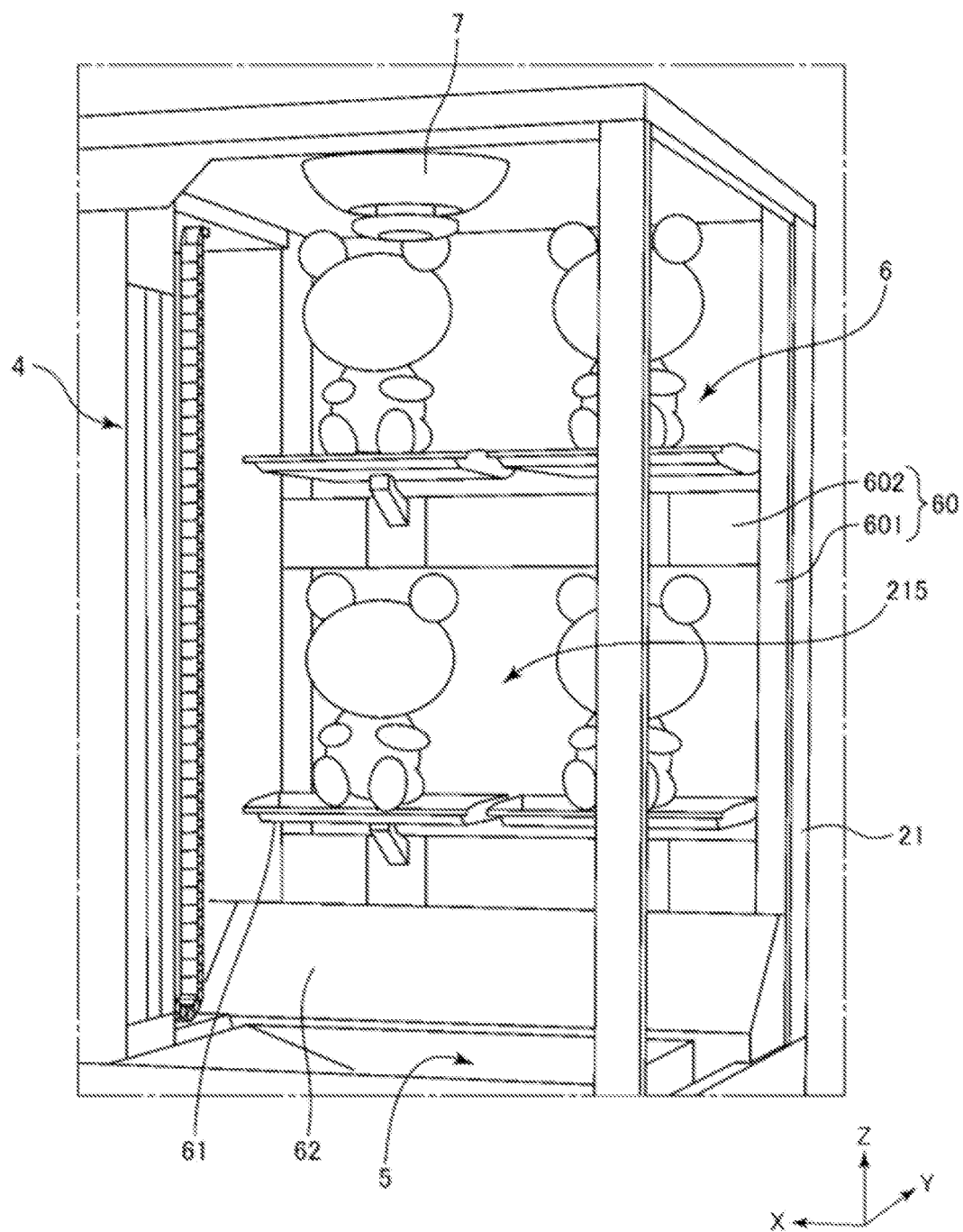


FIG.15

[図16]

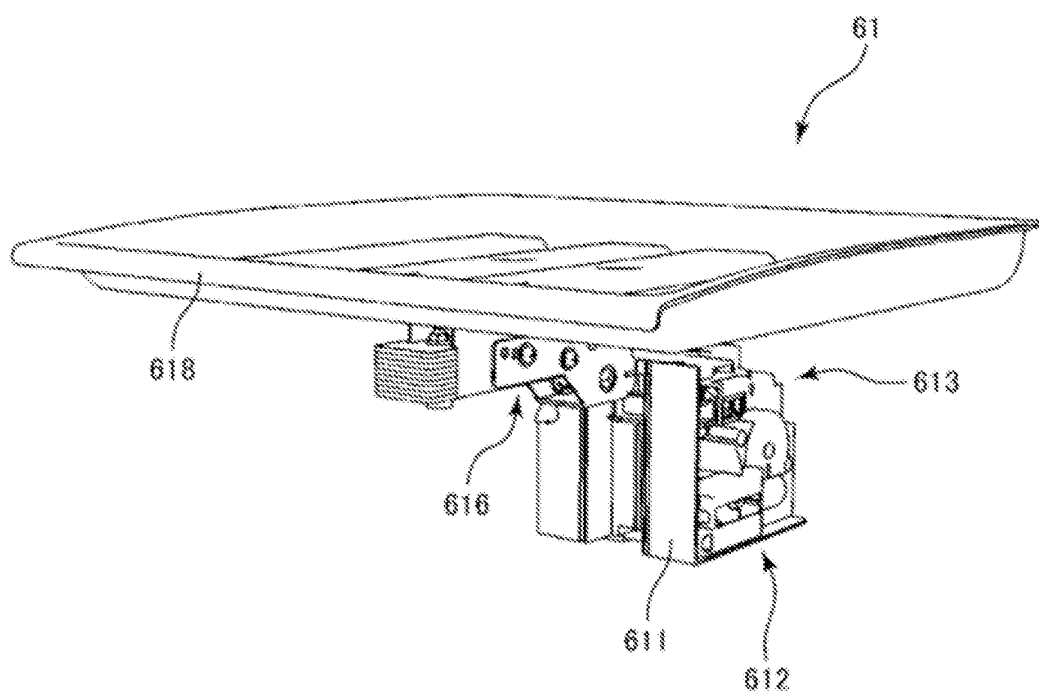


FIG.16

[図17]

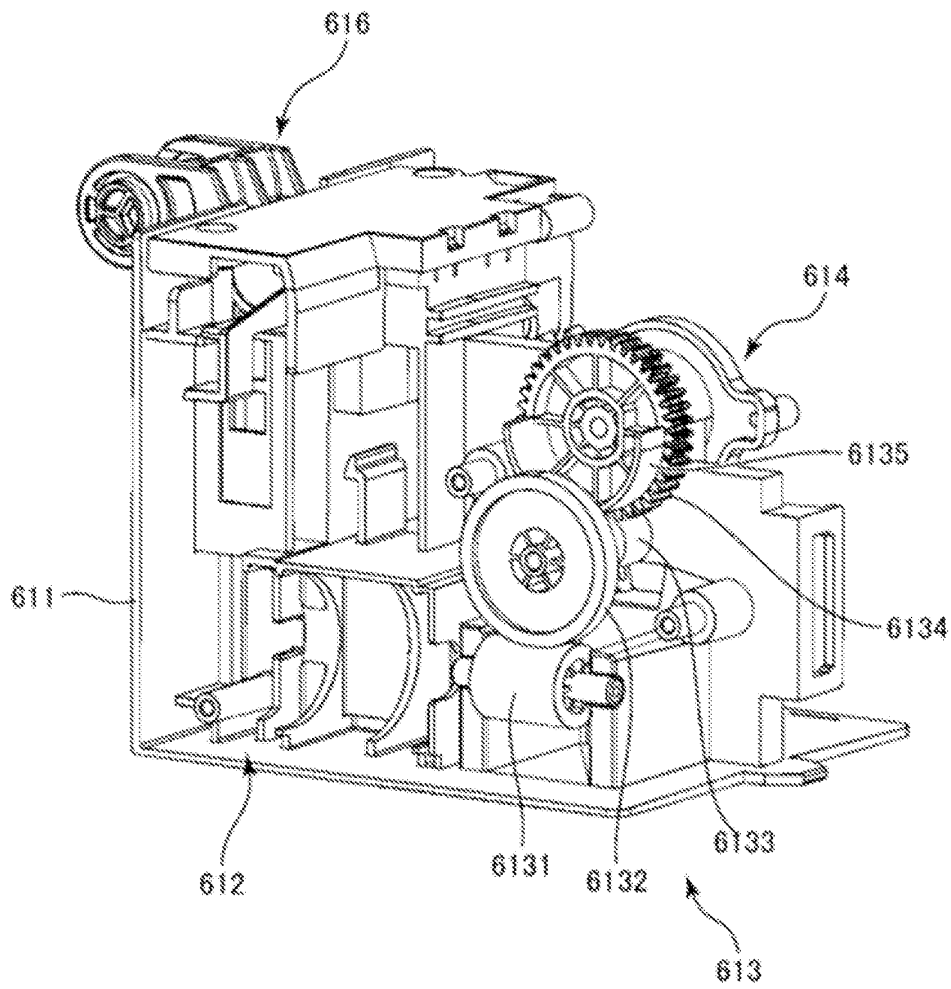


FIG.17

[図18]

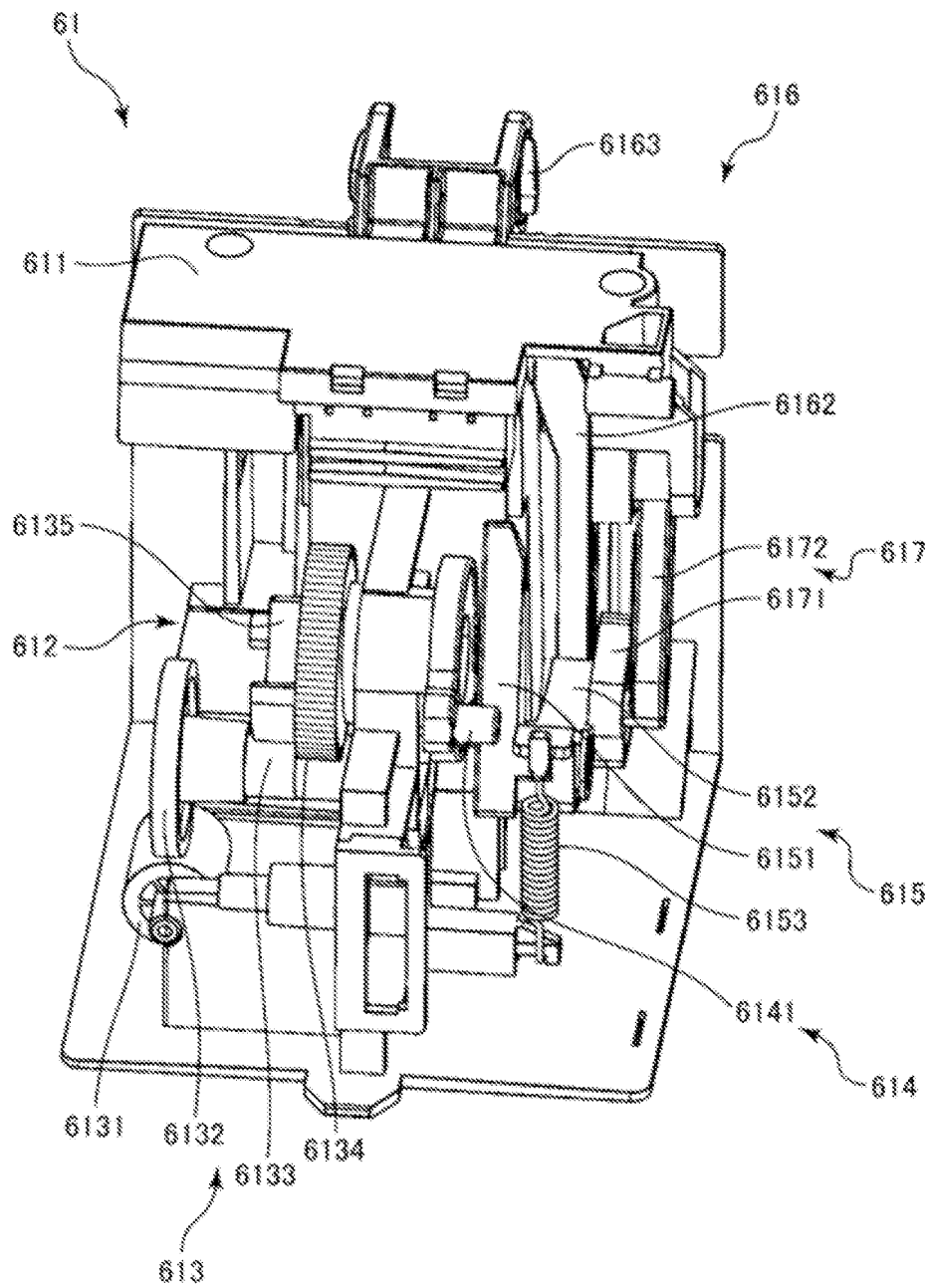


FIG.18

[図19]

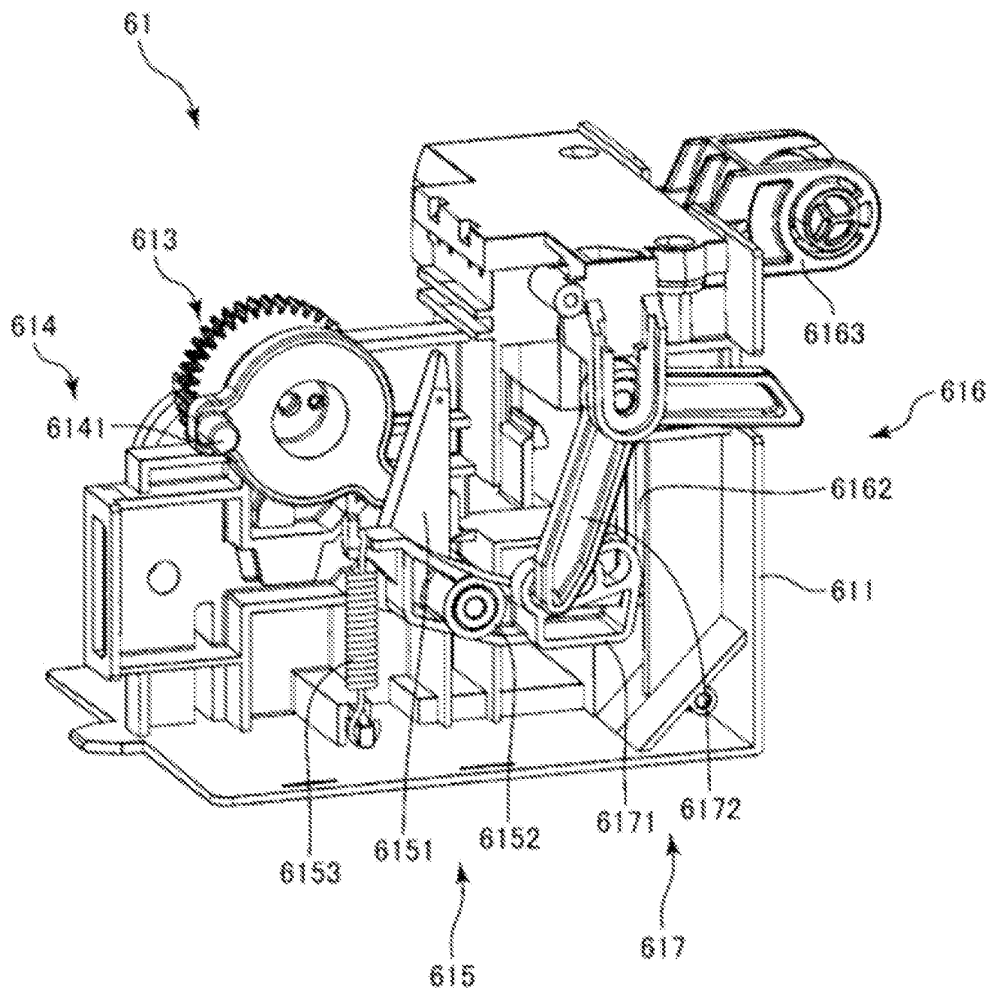


FIG.19

[図20]

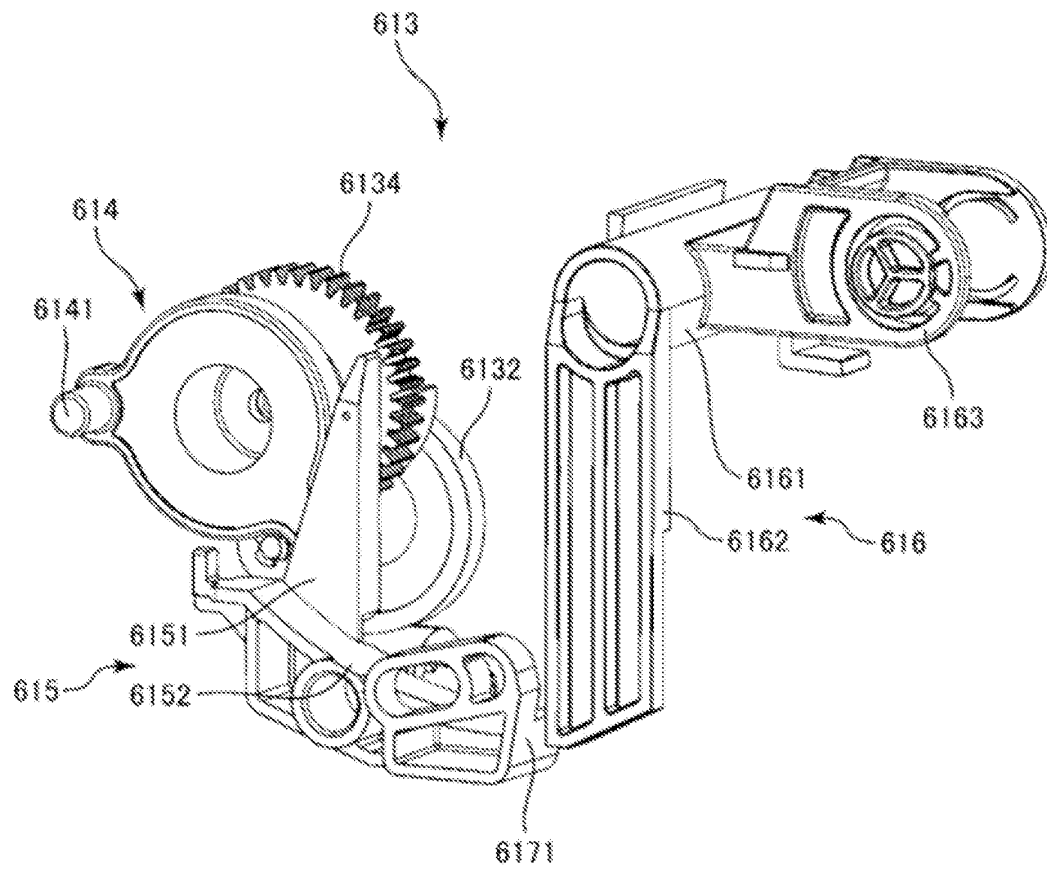


FIG.20

[図21]

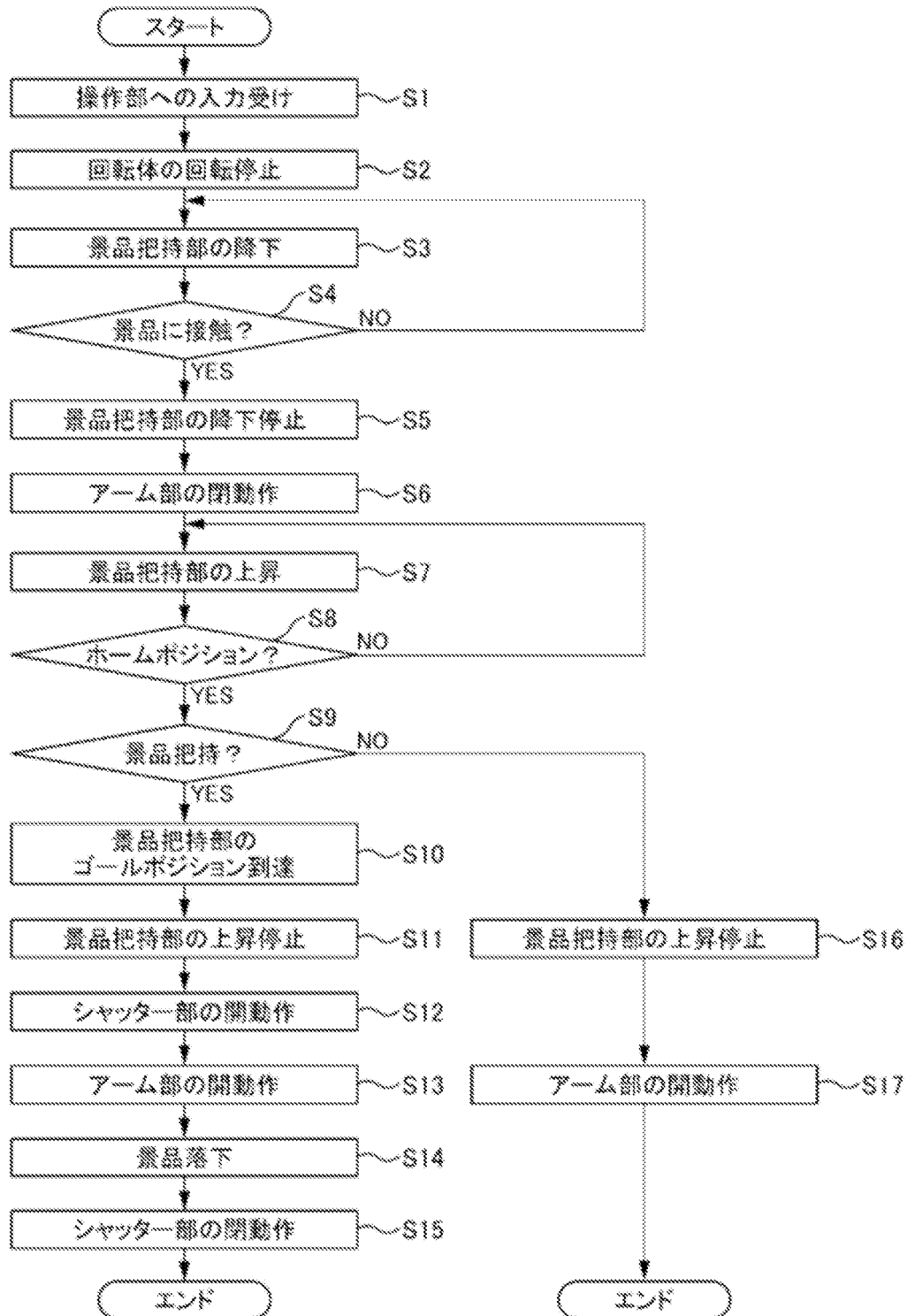


FIG.21

[図22]

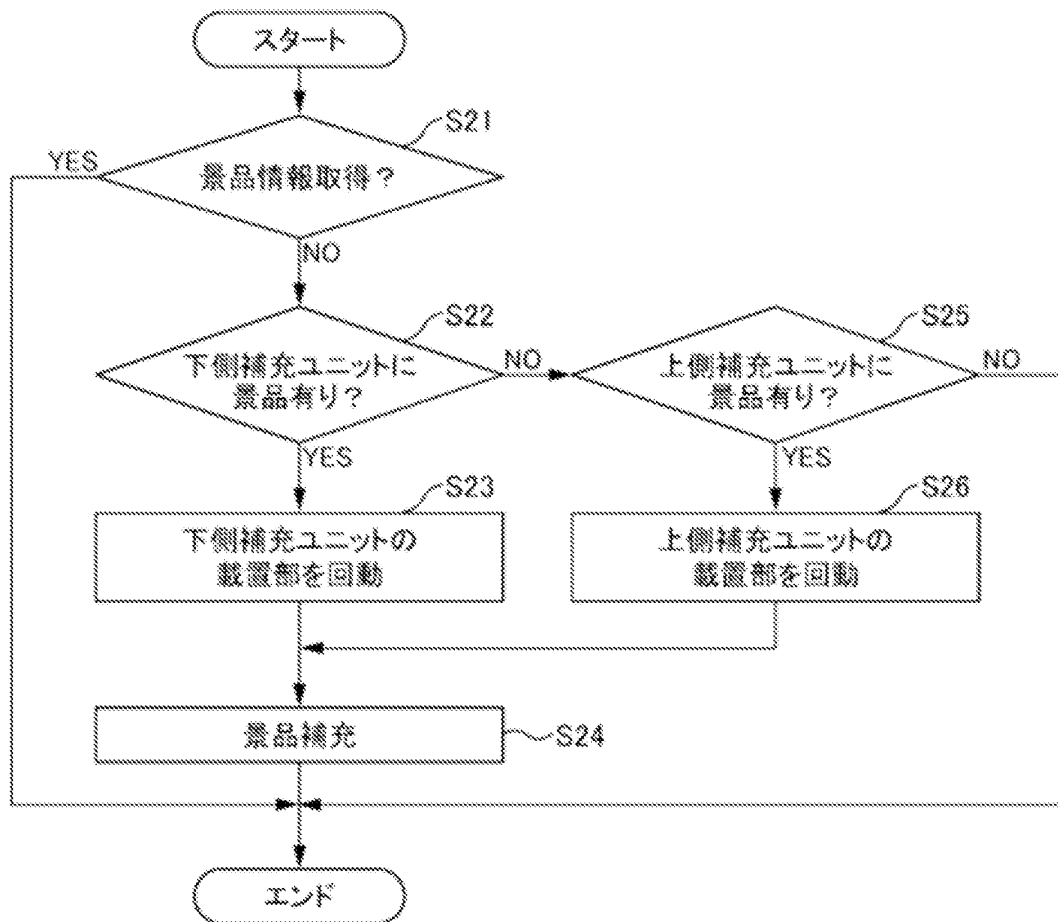


FIG.22

[図23]

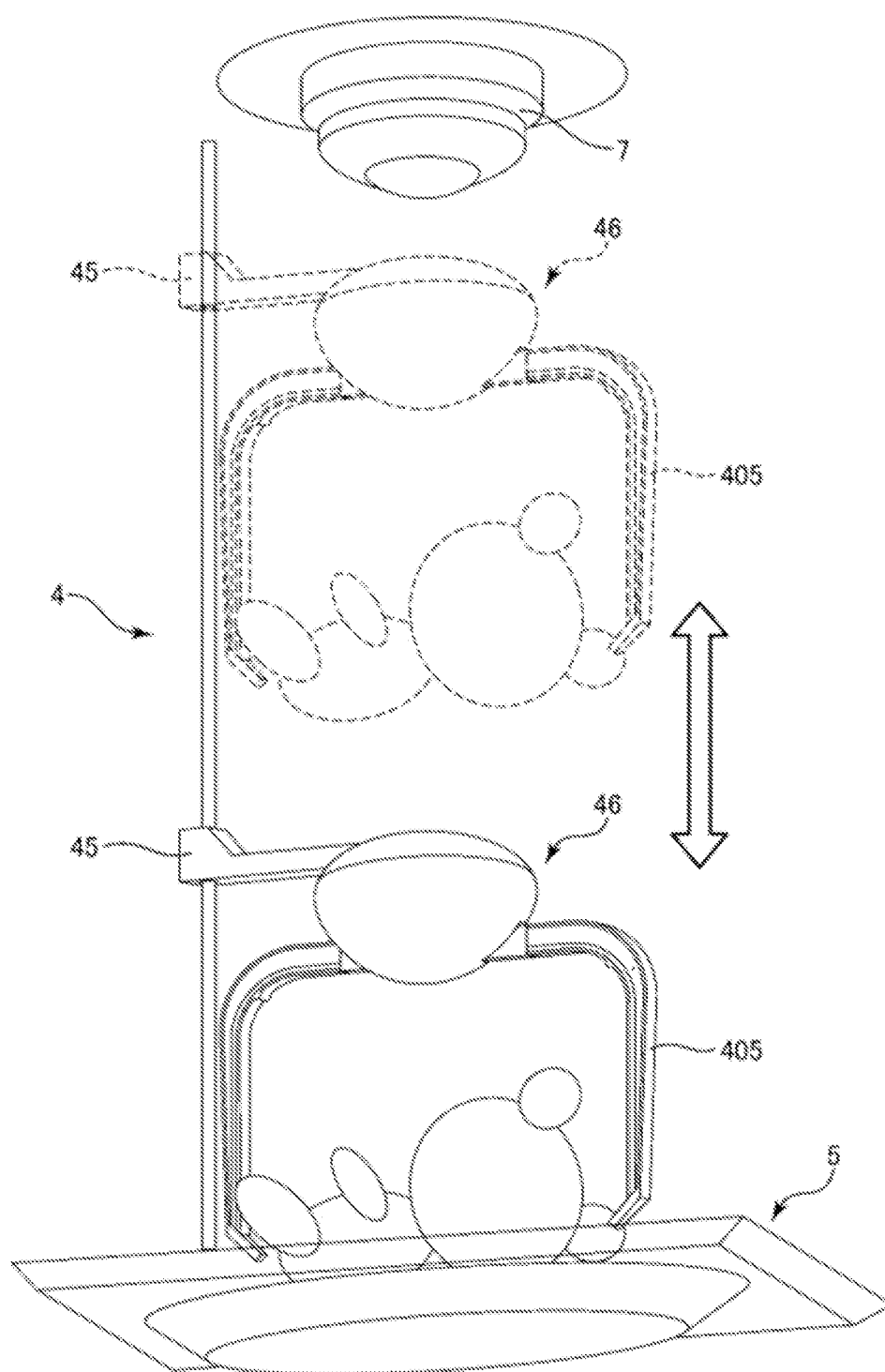


FIG.23

[図24]

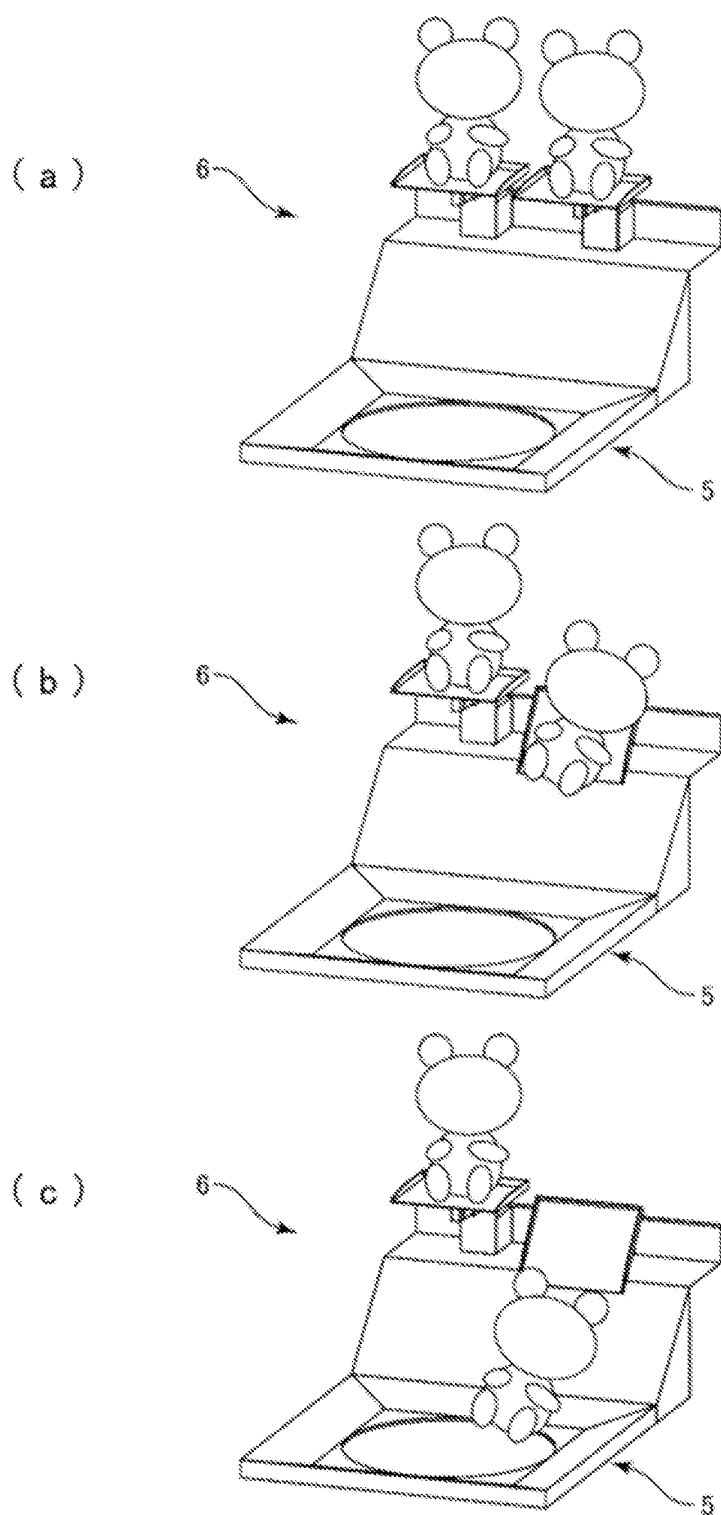


FIG.24

[図25]

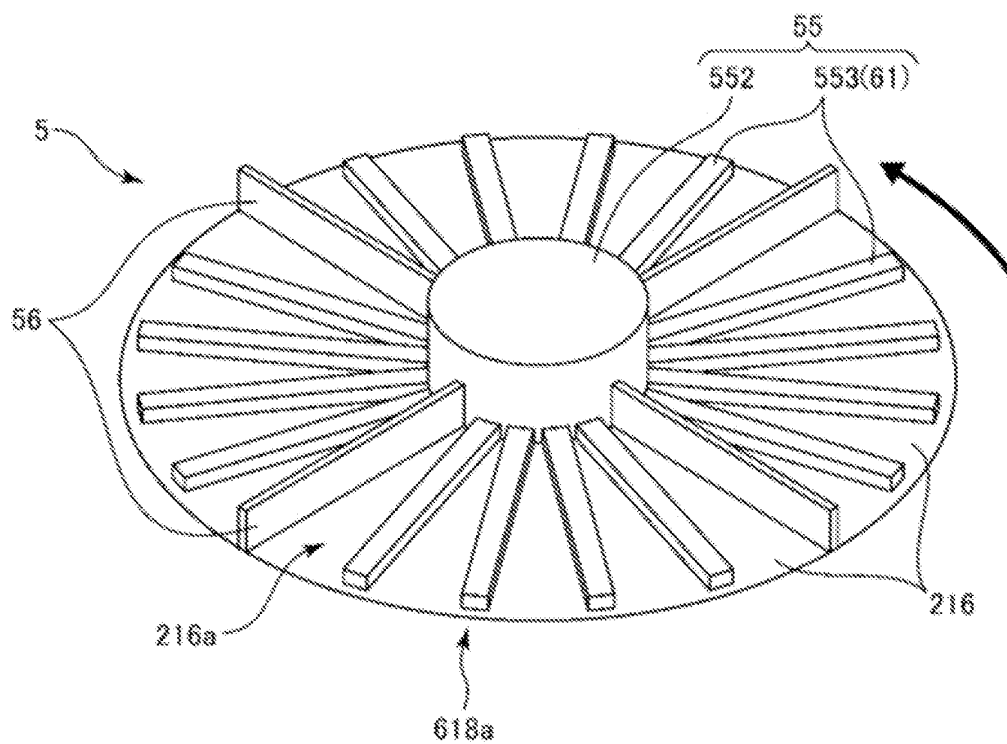


FIG.25

[図26]

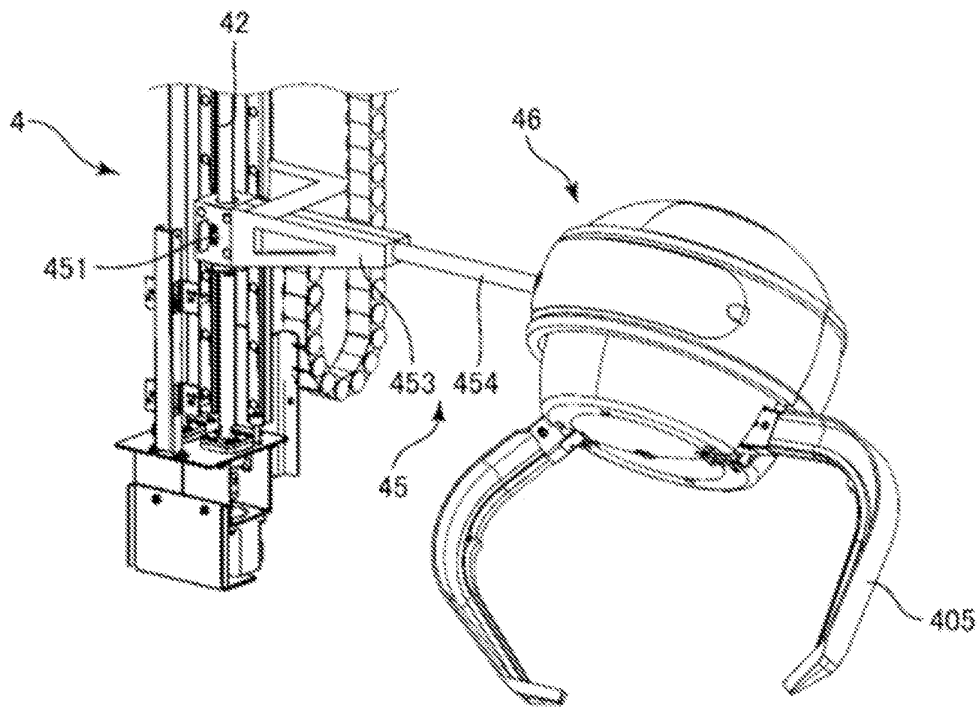


FIG.26

[図27]

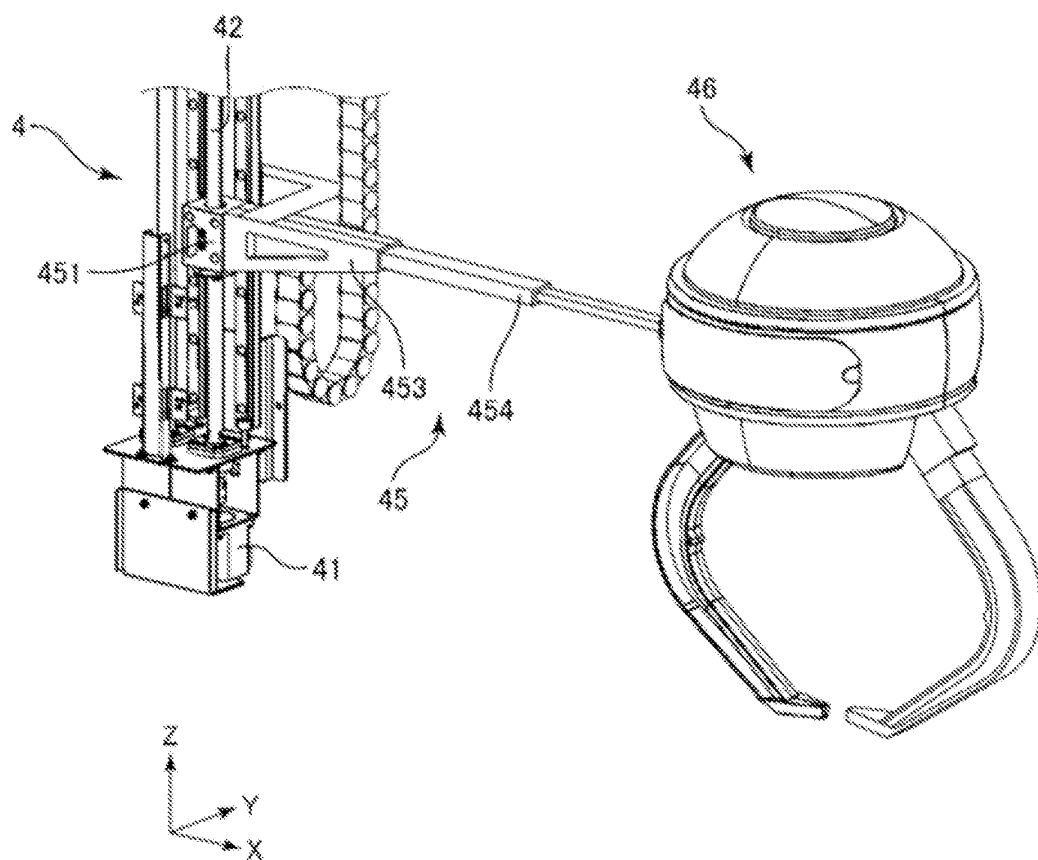


FIG.27

[図28]

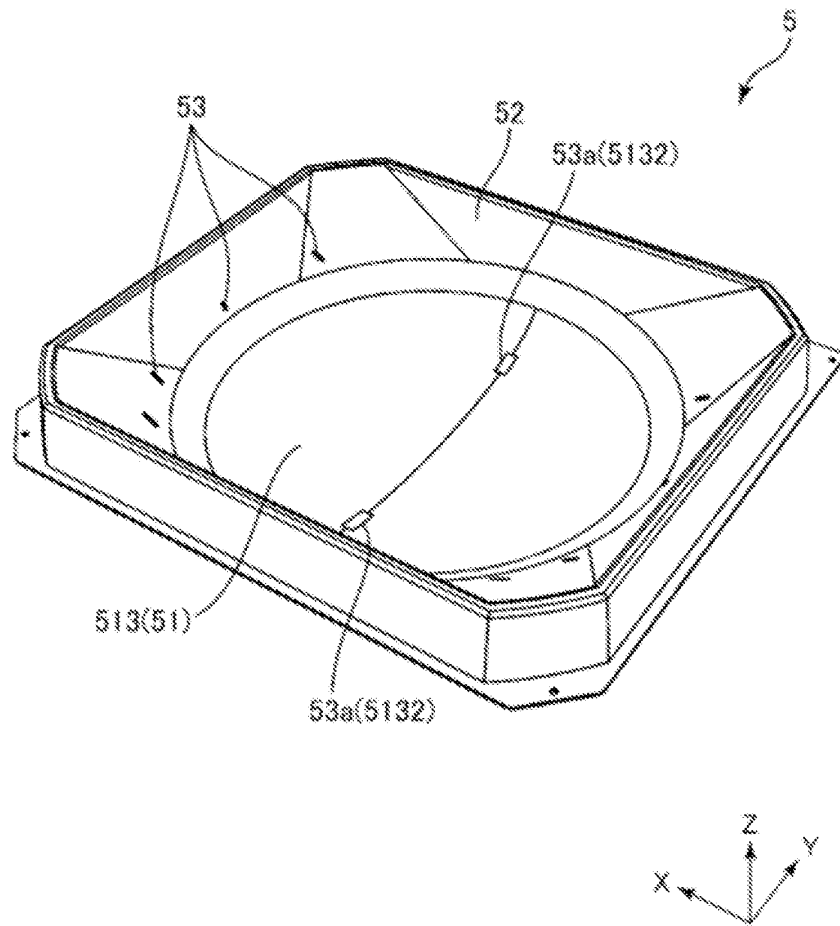


FIG.28

[図29]

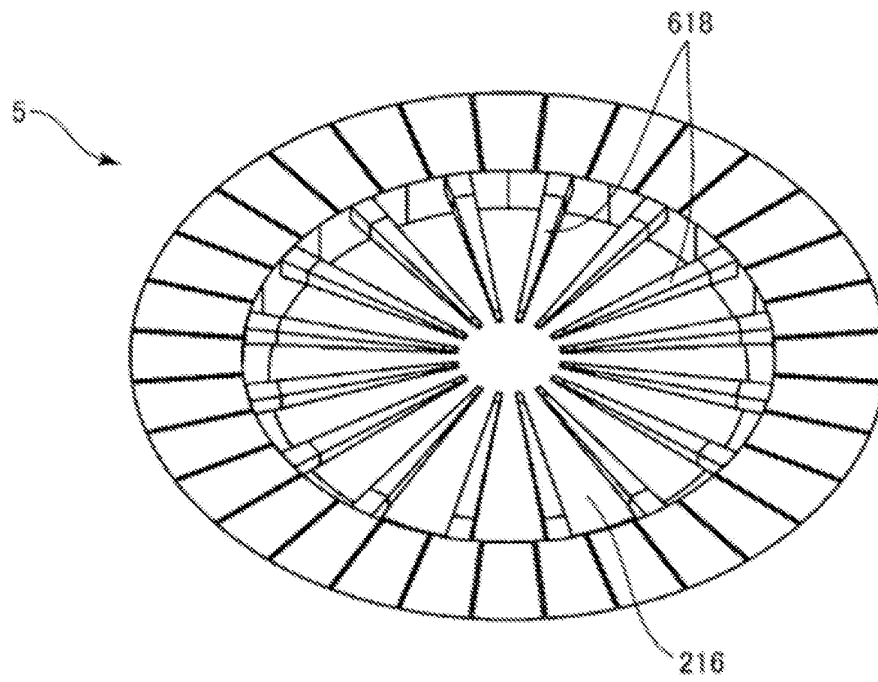


FIG.29

[図30]

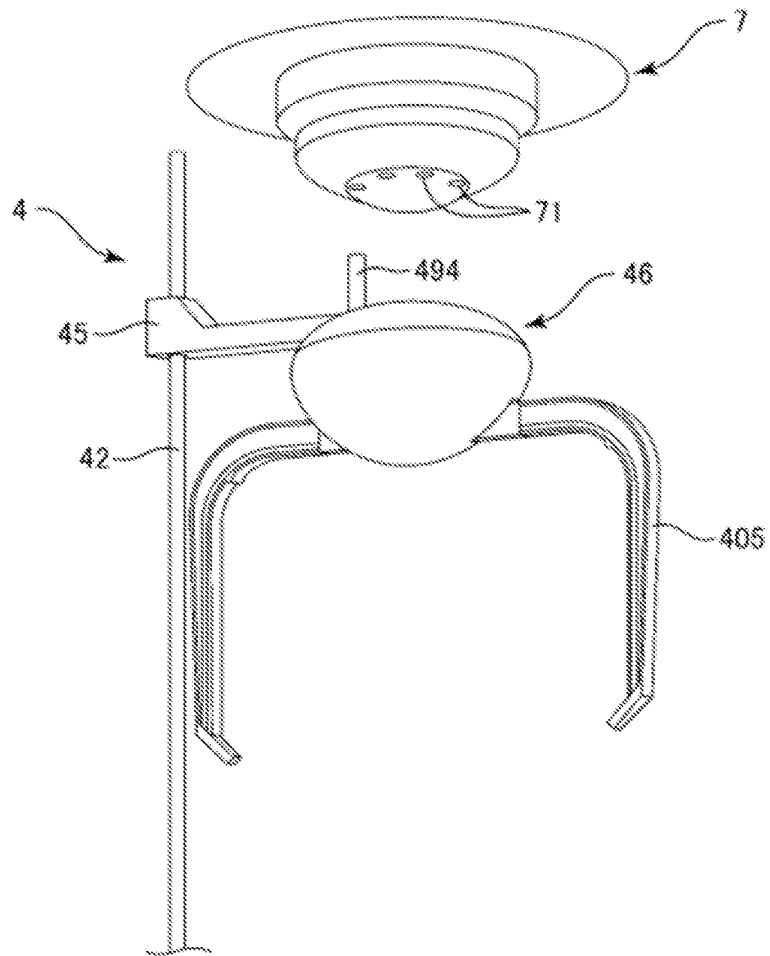


FIG.30

[図31]

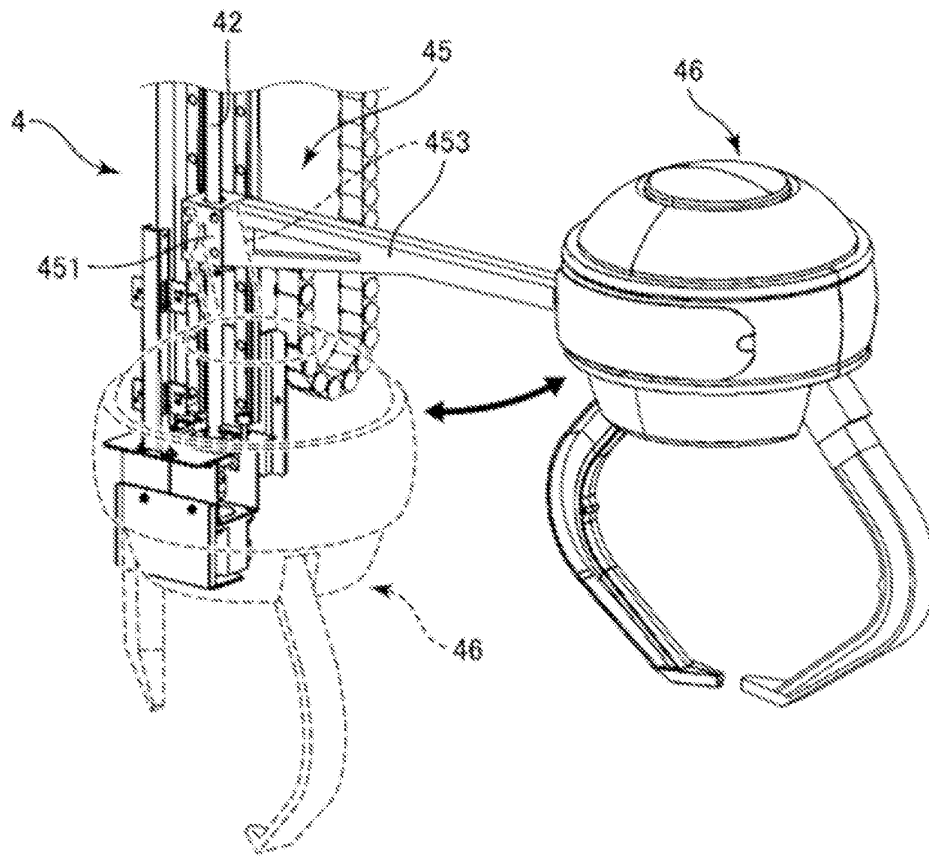


FIG.31

[図32]

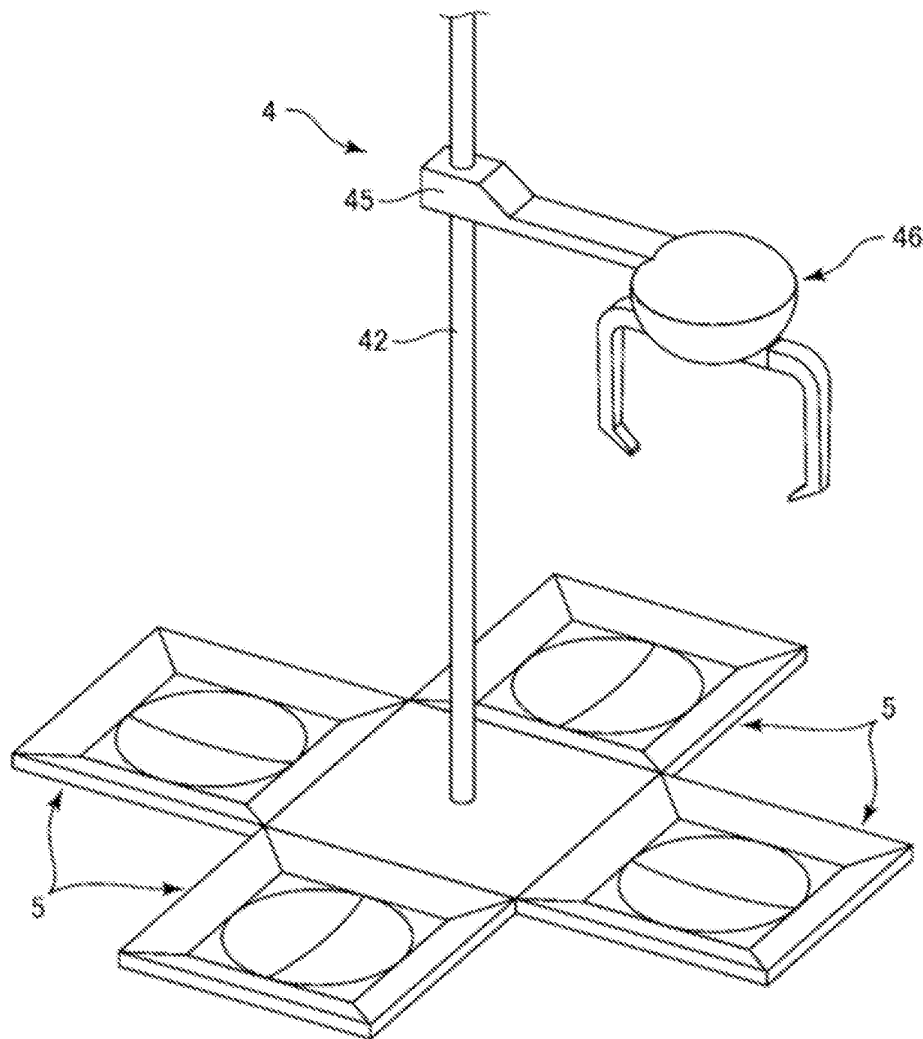


FIG.32